

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 7,053,739 B2
APPLICATION NO. : 10/725573
DATED : May 30, 2006
INVENTOR(S) : Noboru Wakatsuki et al.

Page 1 of 1

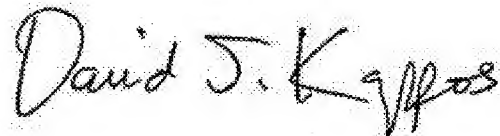
It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 22:

Insert claim 15 as follows:

--15. The device according to claim 1, wherein the base and the projections are formed of a silicon material which is at least partially doped with impurities for providing the resistor in the base and the projections.--

Signed and Sealed this
Twenty-second Day of February, 2011

A handwritten signature in black ink, reading "David J. Kappos". The signature is written in a cursive, flowing style with a large initial "D" and a stylized "K".

David J. Kappos
Director of the United States Patent and Trademark Office